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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**OFFICIAL**

Appl. No. : 09/921,364 Confirmation No. 6223
Applicant : Lucius M. Sherwin
Filed : 8/2/2001
TC/A.U. : 2877
Examiner : Khaled Brown

Docket No. : TI-30661
Customer No. : 23494

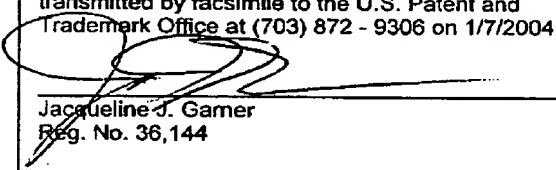
Title : A PARTICLE DETECTION AND REMOVAL APPRATUS
FOR USE ON WAFER FABRICATION EQUIPMENT TO
LOWER TOOL RELATED DEFECTS FROM PARTICLE
CONTAMINATION

AMENDMENT UNDER 37 CFR 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being
transmitted by facsimile to the U.S. Patent and
Trademark Office at (703) 872 - 9306 on 1/7/2004.


Jacqueline J. Garner
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In response to the Office action of 8/1/2003, please amend the above-identified application as follows:

There are no **Amendments to the specification.**

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

There are no **Amendments to the Drawings.**

Remarks/Arguments begin on page 7 of this paper.